10/070973

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO FORM 1449

Atty, Docket No. 10191/2253	Serial No. To Be Assigned
Applicant(s) Thorsten PANNEK et al.	
Filing Date Herewith	Group To Be Assigned

## **U. S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
B	5,220,189 <b>°</b>	June 15, 1993	Higashi et al.			
W	5,695,283*	December 9, 1997	Johnson			

<sup>\*</sup>Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

## FOREIGN PATENT DOCUMENTS

						TRANSLATION	
EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	YES	NO
57	WO 91/02229* ~	February 21, 1991	PCT				
W	1 204 718* -	January 27, 1960	FR				
LST.	0 999 437* - ~	May 10, 2000	EP				
UST	199 32 308" +	January 18, 2001	DE				
Z	100 09 593"	September 13, 2001	DE				

<sup>\*</sup>Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

## OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
W	Gerwen et al., "Thin-Film Boron-Doped Polycrystalline Silicon 70%- Germanium 30% Forthermopiles", Sensors and Actuators A, El Sevier Sequoia S.A., Lausanne, CH Bd. A53, Nr. 1/3, (May 1, 1996), 325-328*

<sup>\*</sup>Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER Ada Market or no citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>\*\*</sup> Described in Specification.